

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Continuation Patent Application of)
Satoshi SHIBATA et al.)
Based On Application No. 09/984,908) Art Unit: 2859
Which Was Filed: October 31, 2001) Examiner: Pruchnic
For: METHOD FOR PREDICTING TEMPERATURE,)
TEST WAFER FOR USE IN TEMPERATURE)
PREDICTION, AND METHOD FOR EVALUATING)
LAMP HEATING SYSTEM) Date: June 23, 2003

REQUEST FOR DRAWING CHANGE APPROVAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached hereto is a copy of Figure 11 with the requested drawing changes shown in red. It is respectfully requested these changes be reviewed and approved by the Examiner prior to the issuance of the subject application.

*DLAN/AC
CH/CH
APR 30
3/2/04*

Respectfully submitted,

By: Thomas W. Cole
Thomas W. Cole
Registration No. 28,290

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102

Telephone: (703) 770-9300